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Swift Heavy Ion irradiation induced nanocrystallisation in Te/Cd/Te trilayer thin films

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Abstract:

In this paper, we report Swift Heavy Ion (SHI) irradiation induced nanocrystallisation

in Te/Cd/Te trilayer thin films. In the present investigation, thermally evaporated Te/Cd/Te

trilayer thin films were irradiated by 100 MeV ¹⁰⁷Ag ion beam at varying fluence. The

structural characterization of Te/Cd/Te trilayer thin films was carried out using X-ray

Diffraction (XRD) technique. XRD studies revealed that SHI irradiation results in Te/Cd/Te

layer mixing leading to formation of CdTe nanocrystalline phase. Scanning Electron

Microscopy (SEM) and Atomic Force Microscopy (AFM) were employed for surface studies.

SEM studies indicate ion beam induced surface modifications. Further, AFM pictures

indicate nano grain formation in the irradiated films. The elemental analysis of trilayer films

before and after irradiation was carried out using Energy Dispersive X-ray Spectroscopy

(EDX). EDX analysis indicates that percentage ratio of Cd and Te remains unaffected after

SHI irradiation. Optical characterization was done using UV-Vis spectroscopy. Band gap

values determined on the basis of UV-Vis spectroscopy of all the irradiated films were found

to be more than the reported bulk value of 1.5 eV. The increase in bandgap value is attributed

to the combined effect of ion induced strain and quantum confinement effect. SHI irradiation

induced formation of nanocrystallisation in Te/Cd/Te trilayer films is explained mainly in the

framework of Ion Beam Mixing (IBM).

Keywords: Nanocrystalline CdTe, SHI, XRD, SEM, AFM, UV-VIS Spectroscopy.

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